



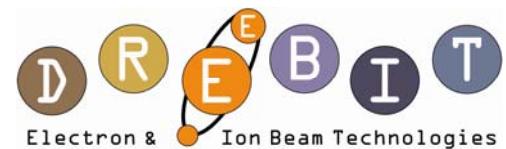
Dresden Electron Beam Ion Sources: Latest Developments

G.Zschornack, M.Kreller, A.Silze
Dresden University of Technology

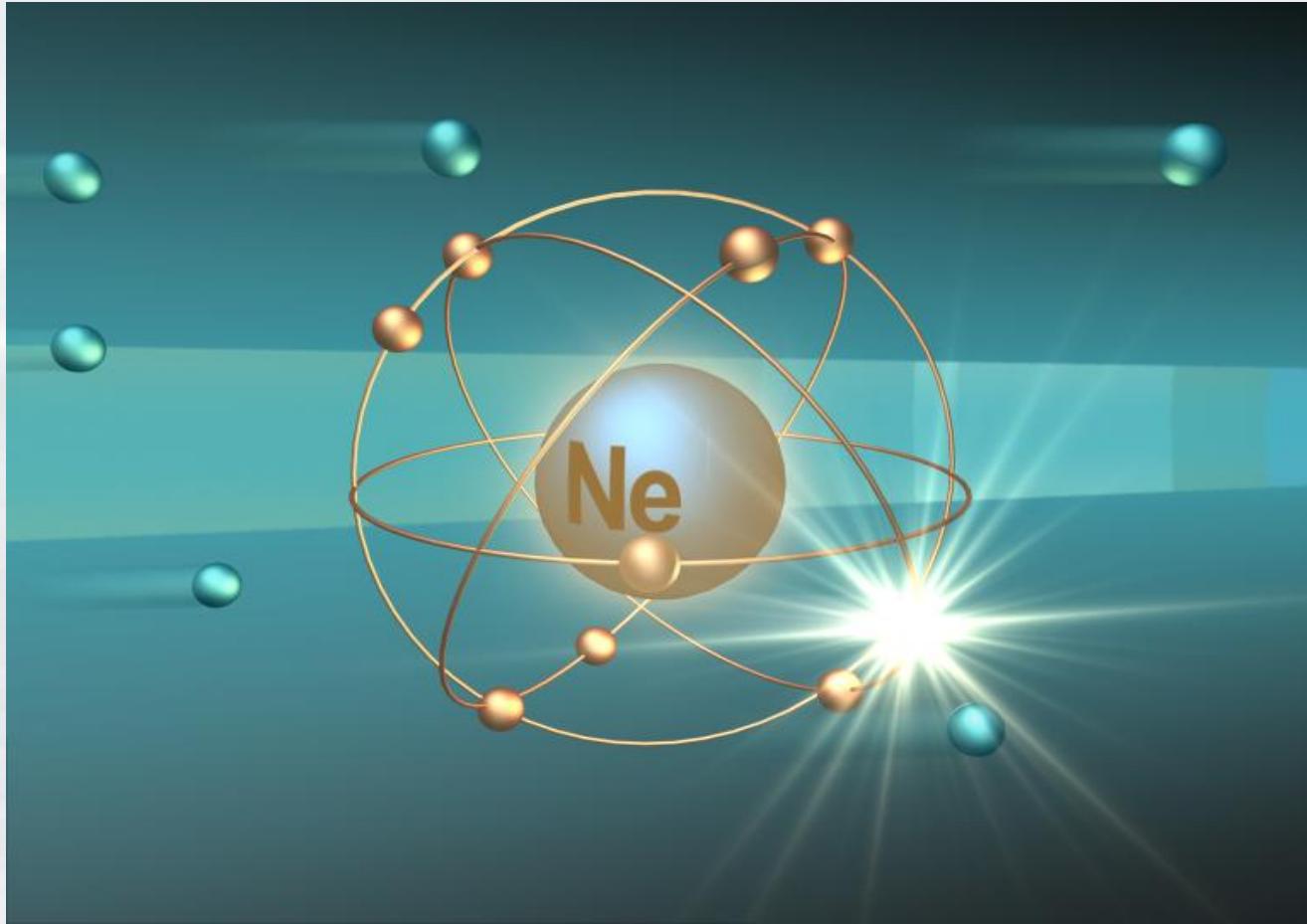
V.P.Ovsyannikov, F.Grossmann,
R.Heller, U.Kentsch, M.Schmidt,
A.Schwan, F.Ullmann
DREEBIT GmbH Dresden



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Exciting Properties of Highly Charged Ions

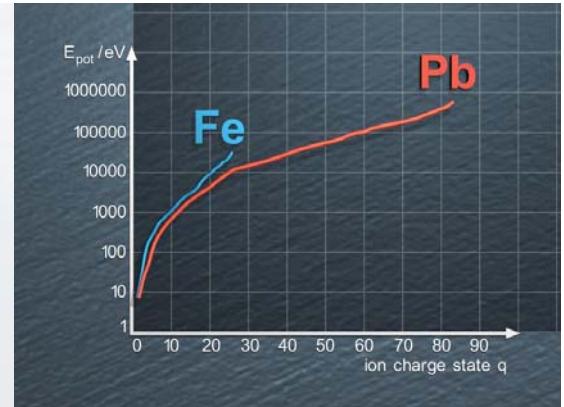


Exciting Properties of Highly Charged Ions

Potential energy

The potential energy of an ion increases with the degree of ionization

Example: Xe^{44+} has a potential energy that is **4600 times** higher than that of Xe^{1+}



High power deposition into the surface

The deposition of potential energy leads to ultrafast intense electronic excitations

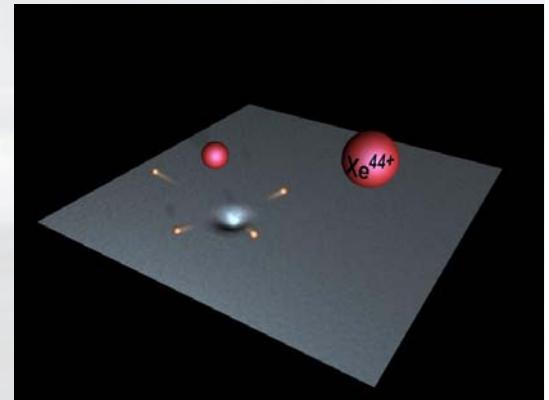
Power deposition: **$10^{12} \dots 10^{14} \text{ W/cm}^2$**

High yield of secondary particles

Irradiation with highly charged ions results in up to **300 times** higher secondary particle yields

High specific energy gain for ion acceleration

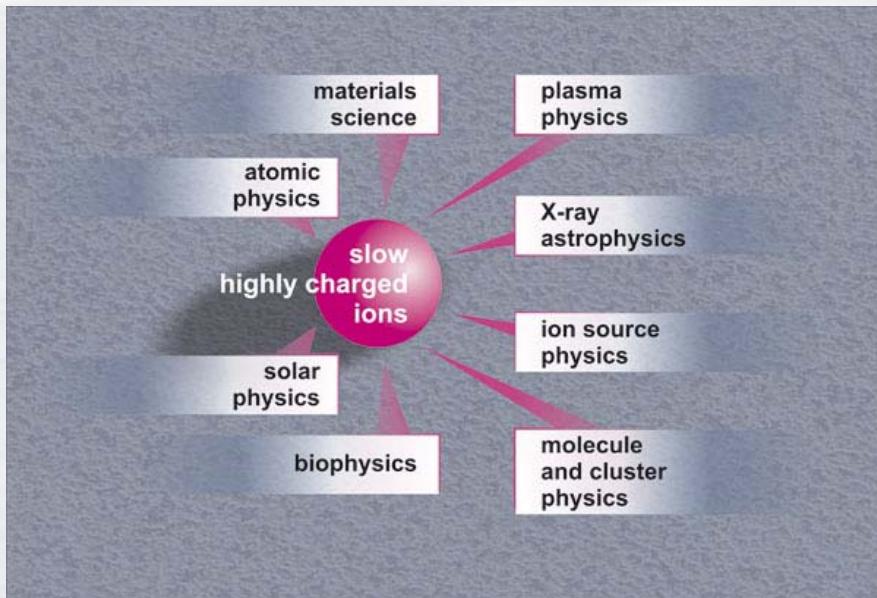
linear accelerator: $\sim q$ effective ion acceleration
cyclical accelerator: $\sim q^2$



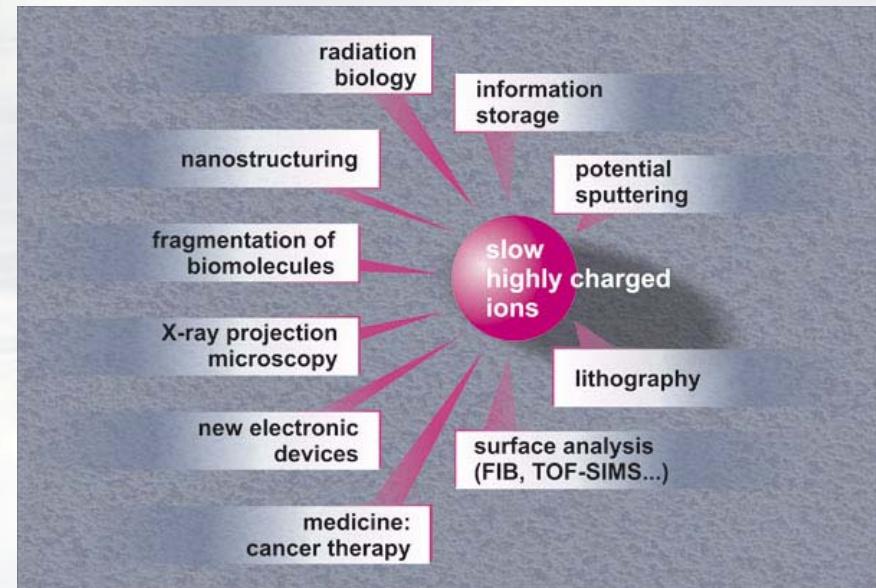
Applications of Highly Charged Ions

The interest of using **highly charged ions** in both basic and applied research increases continuously

Basic Research



Applied Technology

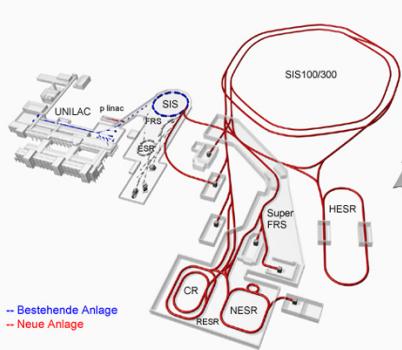


How to produce highly charged ions



Ion Accelerators (GSI, TSR HD)

Stripping
→ up to bare nuclei at
high projectile energies



(© GSI Darmstadt)

up to U^{92+}

ECR Ion Sources

Electron Cyclotron Resonance (ECR)
heating of a
magnetically confined
plasma

Ar^{16+} , Ta^{38+} , Au^{41+}



Electron Beam Ion Sources/Traps

Ionization in high-dense
electron beams

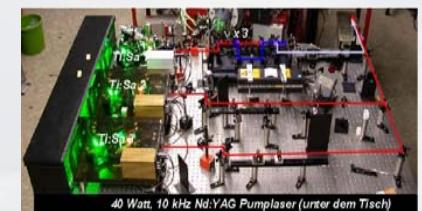
electron beam
compression in strong
magnetic fields

up to small
amounts of U^{92+}



Laser Ion Sources

Pulsed laser irradiation of
selected targets



(© Uni Mainz)

Pb^{27+} etc.

EBIT / EBI S



EBIT / EBIS



Germany is the land with the highest EBIT/EBIS density!

Cryogenic EBIT/EBIS:

MPIK Heidelberg
TU Dresden
MPIP Berlin
DESY Hamburg
GSI Darmstadt

Warm EBIT/EBIS:

TU Dresden
FZ Dresden-Rossendorf
FSU Jena
University Duisburg-Essen
GSI Darmstadt

EBIT Design

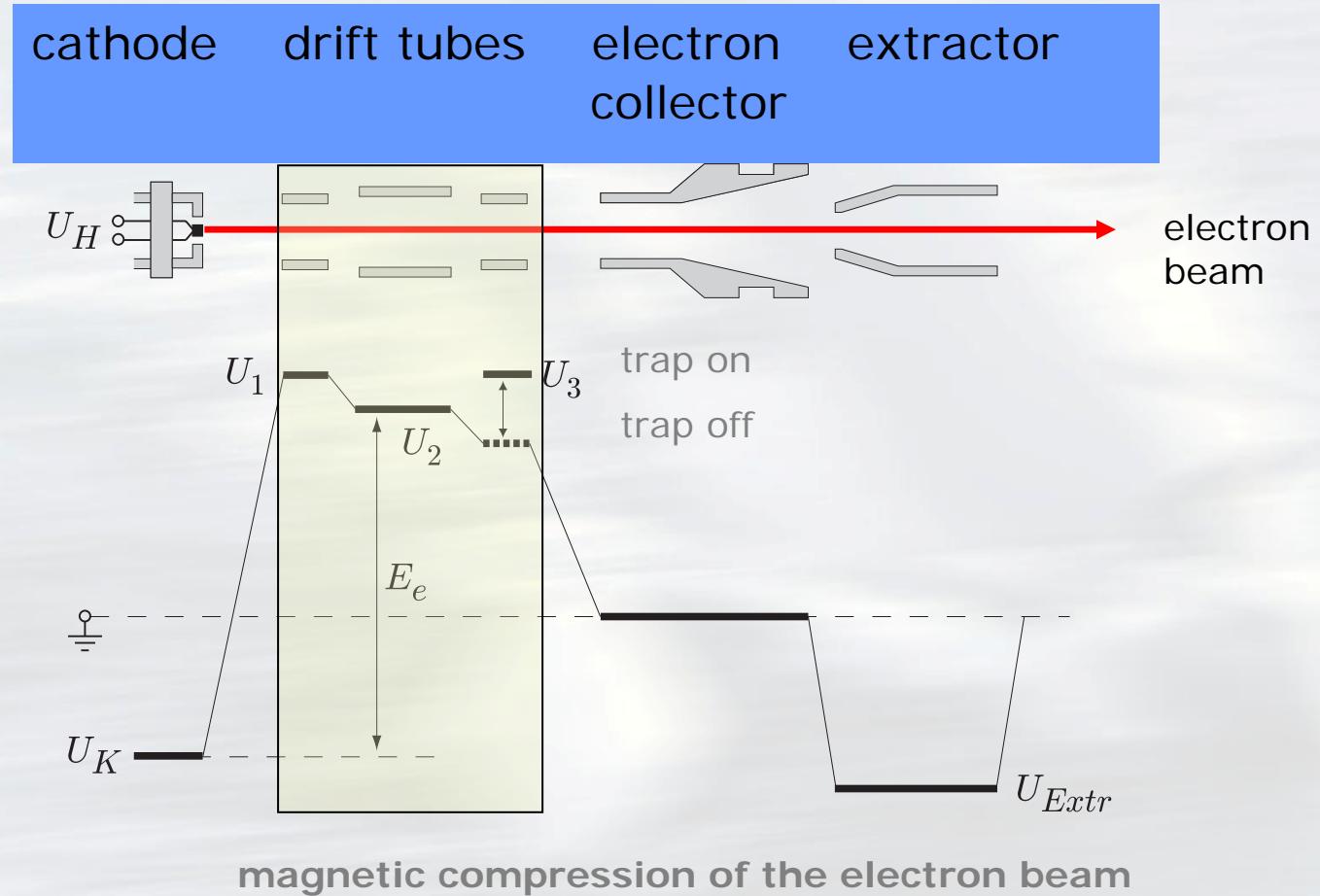
„classical“ cryogenic EBIT

- superconducting coils
→ (3... 8) T magnetic field
 $\Rightarrow j_e > 1000 \text{ A/cm}^2$
- highest charge states
 $\text{Xe}^{(52\ldots 54)+}$, up to $\text{U}^{(90\ldots 92)+}$
- large devices,
liquid helium cooling
- latest developments:
Refrigerator cooling

room-temperature EBIT

- permanent magnets (SmCo, NdFeB)
(250...620) mT at the axis
 $\Rightarrow j_e = (200\ldots 600) \text{ A/cm}^2$
- bare ions up to $Z=28$,
 Kr^{34+} , $\text{Xe}^{(44\ldots 48)+}$, Ir^{67+}
- compact, transportable,
low initial and maintenance
costs,
short setup times

Dresden EBIT/EBIS: principle of operation



Room-Temperature Sources of Highly Charged Ions



Dresden EBIT

Dresden EBIS

Dresden EBIS-A

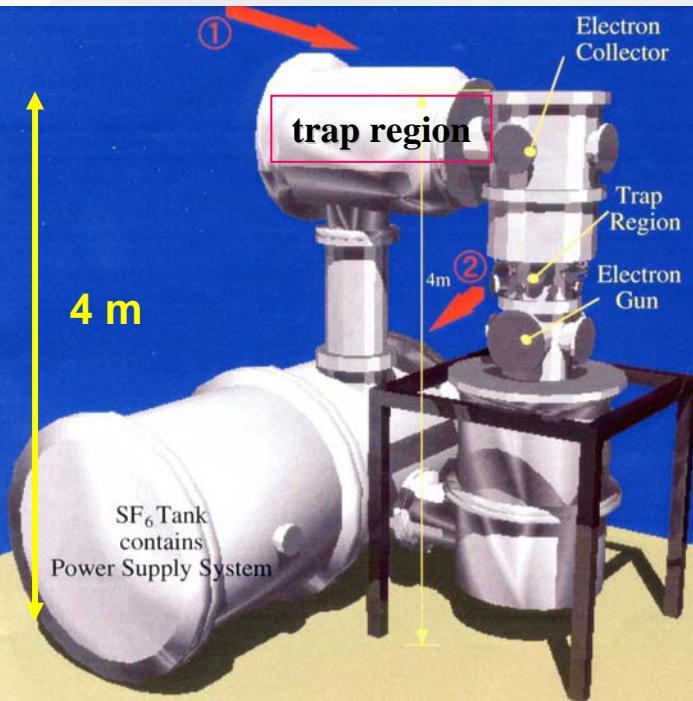
- Low initial and maintenance costs
- Low specific price per ion
- Compact device, simple to operate
- Long-term stable, reliable
- Photon spectroscopy inside the trap
- Ion extraction with small beam emittance

Room-Temperature Sources of Highly Charged Ions – Technical Parameters

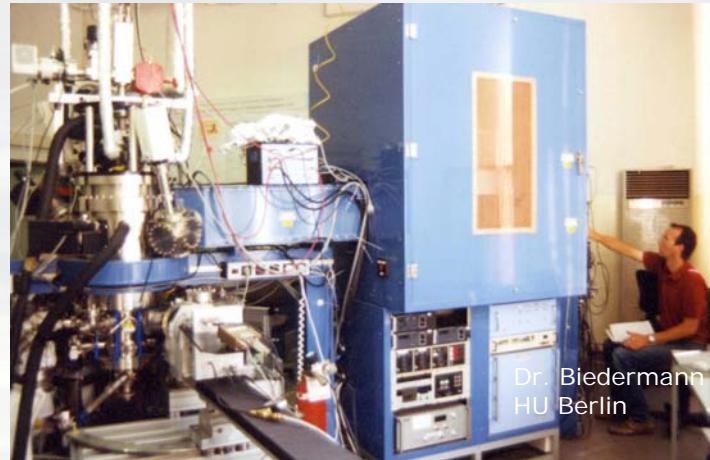
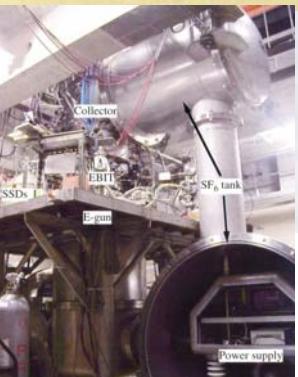


parameter	Dresden EBIT	Dresden EBIS	Dresden EBIS-A
B / mT	250	400	600
max. E_e / keV	15	25	30
max. I_e / mA	50	100	200
j_e / A cm ⁻²	< 300	< 300	< 600
L / cm	2	6	6
N	3	3	3
magnet	SmCo	NdFeB	NdFeB

Comparison of Sizes



Tokyo EBIT



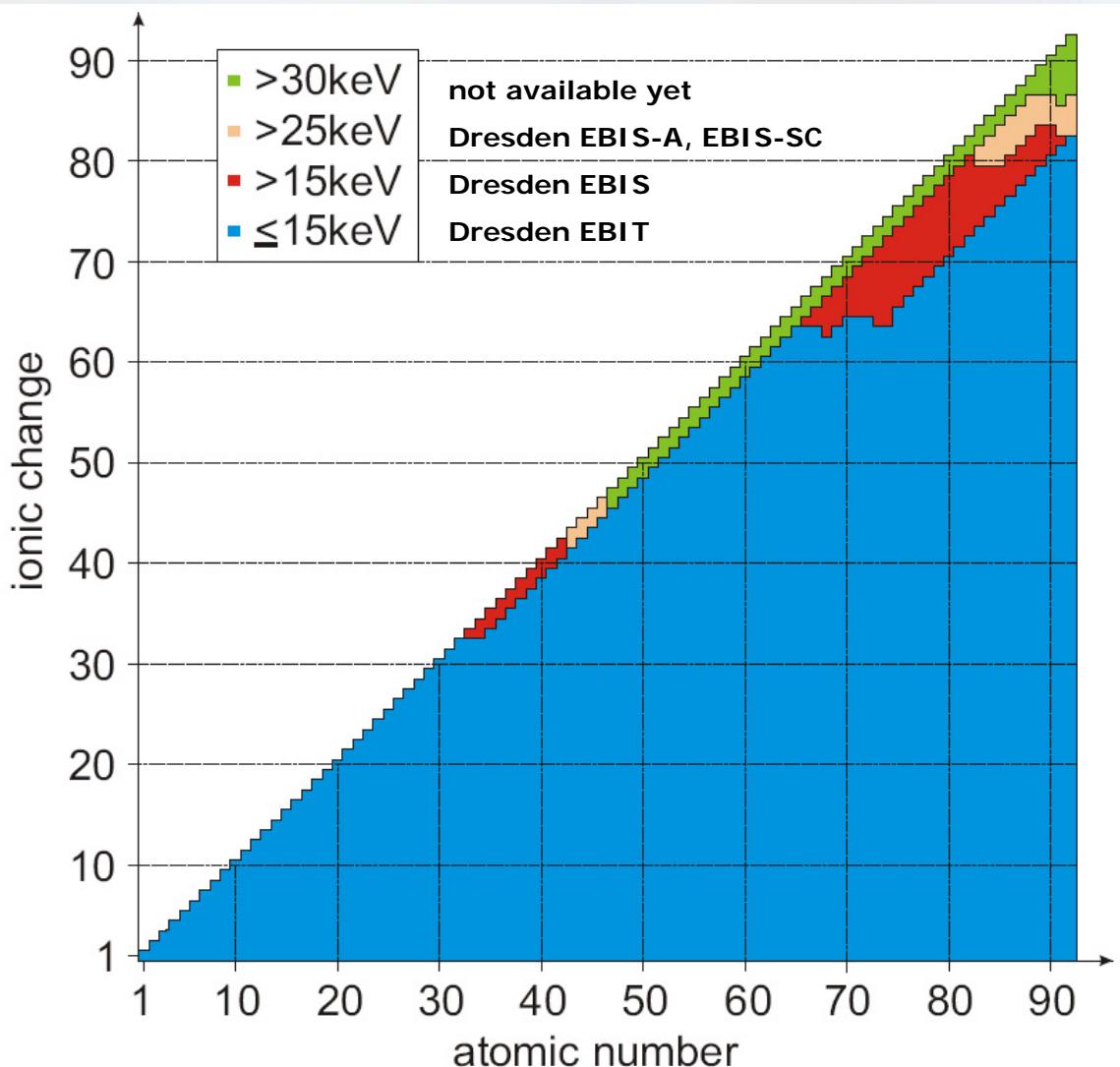
LLNL
EBIT

(photo MPI für
Plasmaphysik
Berlin)



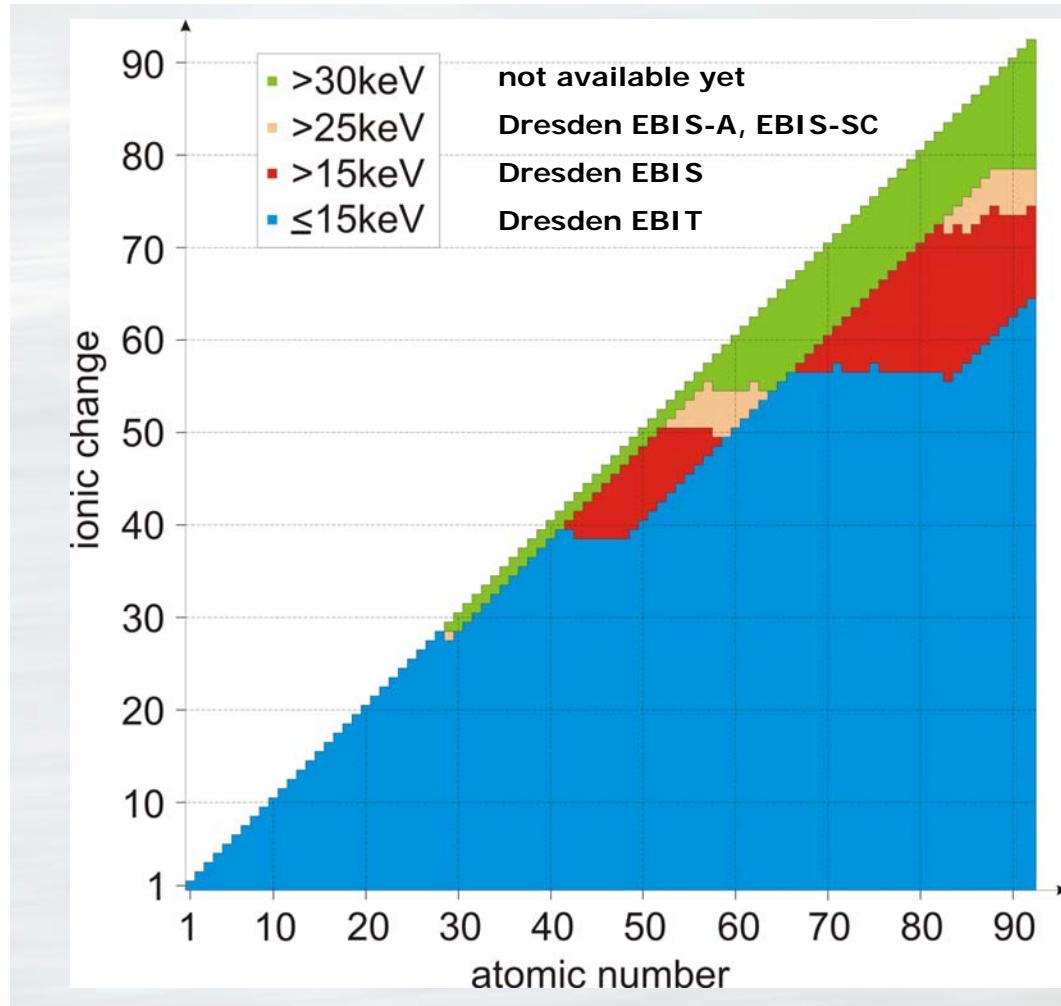
Dresden
EBIT

Ultimative Limits of Ion Production – Selection of Electron Energy



Even the Dresden EBIT
is able to produce most
of the possible ion
charge states of all
stable elements!

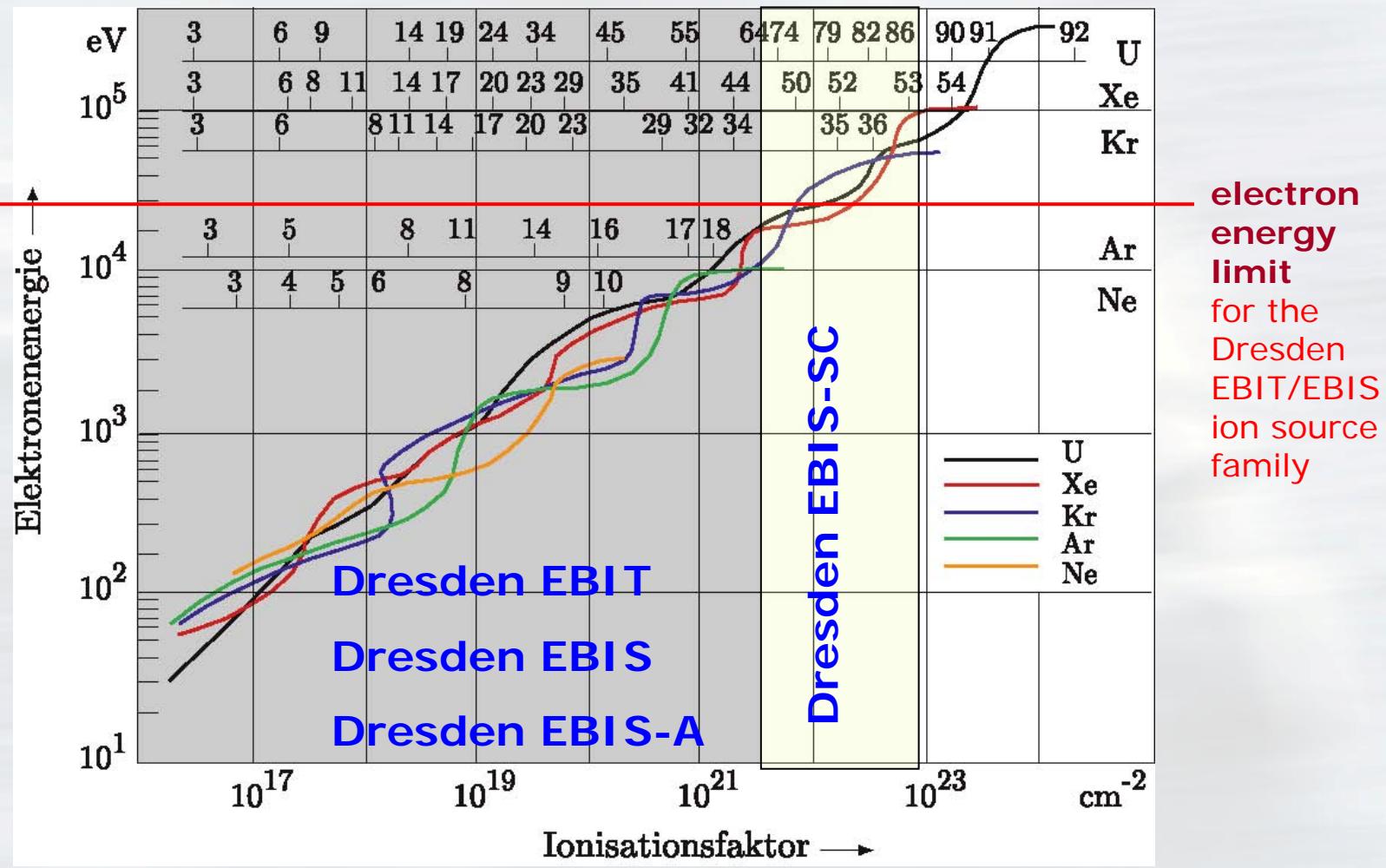
Ion Production at Optimal Electron-Impact Ionization Cross-Sections



The optimal ionization cross-section occurs at

$$2.7 \times E_B$$

Limits of Ion Production – Ionization Factor



Upper Limit of the Electrical Trap Capacity

$$C = 1 * 10^{13} * L[m] * I_e [A] * \alpha * f / (E_e [eV])^{1/2} \quad \text{elementary charges}$$

L – trap length

I_e – electron beam current

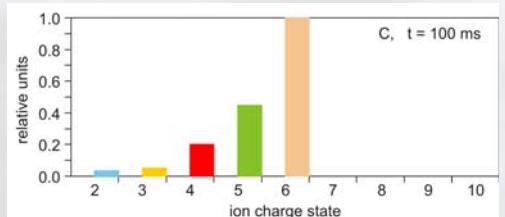
E_e – electron energy

α - ratio of useable ions in the ion charge state distribution

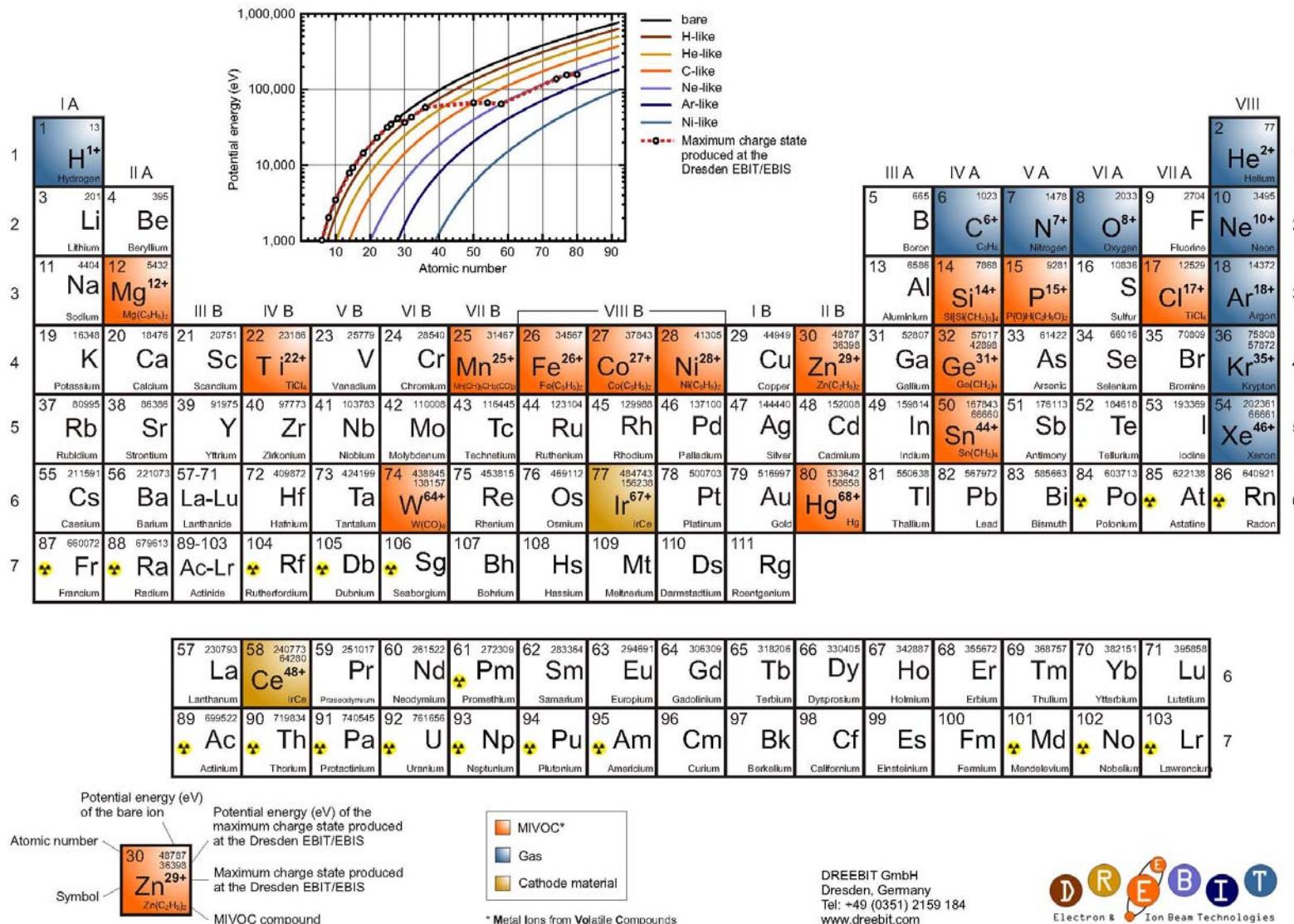
f - compensation of the electron beam

Ion source	max. trap capacity
Dresden EBIT	3×10^8 e
Dresden EBIS	2×10^9 e
Dresden EBIS-A	4×10^9 e
Dresden EBIS-SC	6×10^{10} e

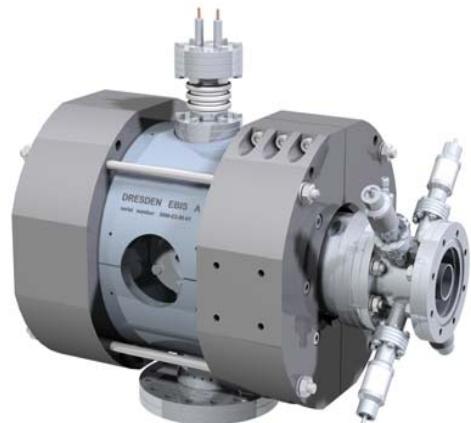
role of α



Examples of Produced Ions



EBIS(W): An Innovative New Generation of Ion Sources



+



=

**new
product**

EBIS

+

Wien filter

→

**ion beams with
individual ion charge states**

„W“ – Family : A new Generation of Ion Sources



Dresden EBIT-W

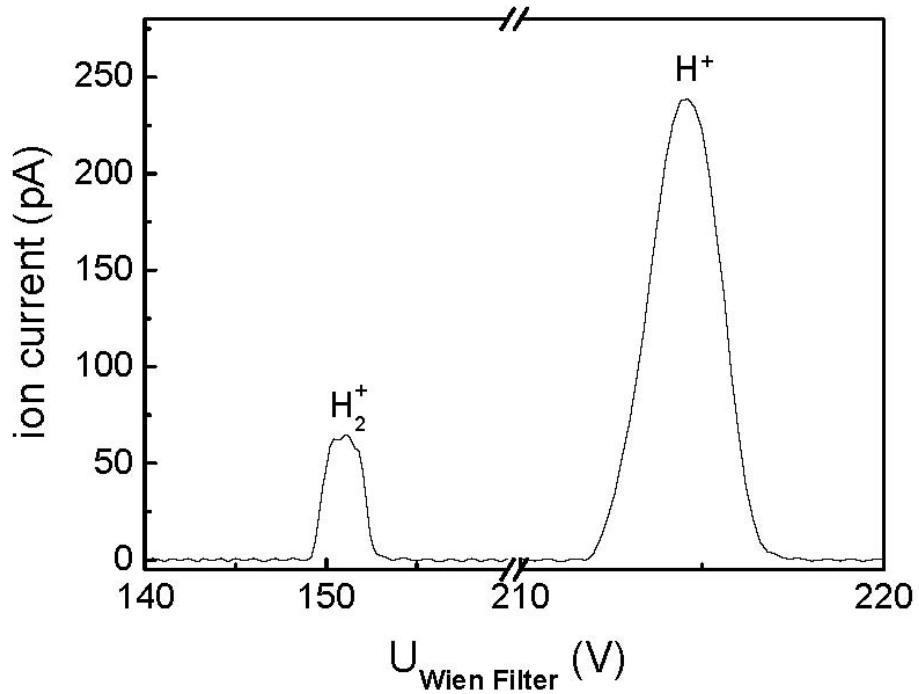
Dresden EBIS-W

Dresden EBIS-AW

New product family:

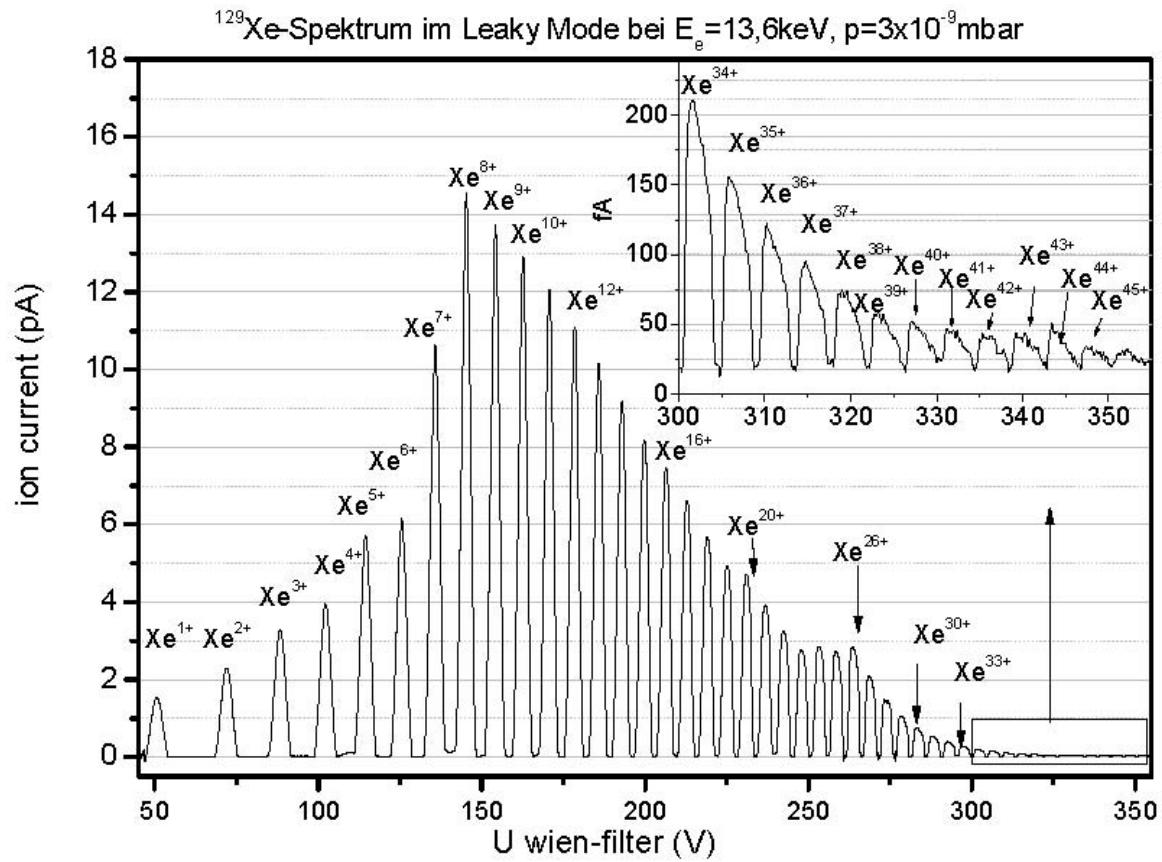
EBIS/T with integrated Einzel lense and Wien filter

„W“ – Family : Some Ion Extraction Spectra



Dresden EBIS
Leaky mode
 H_2

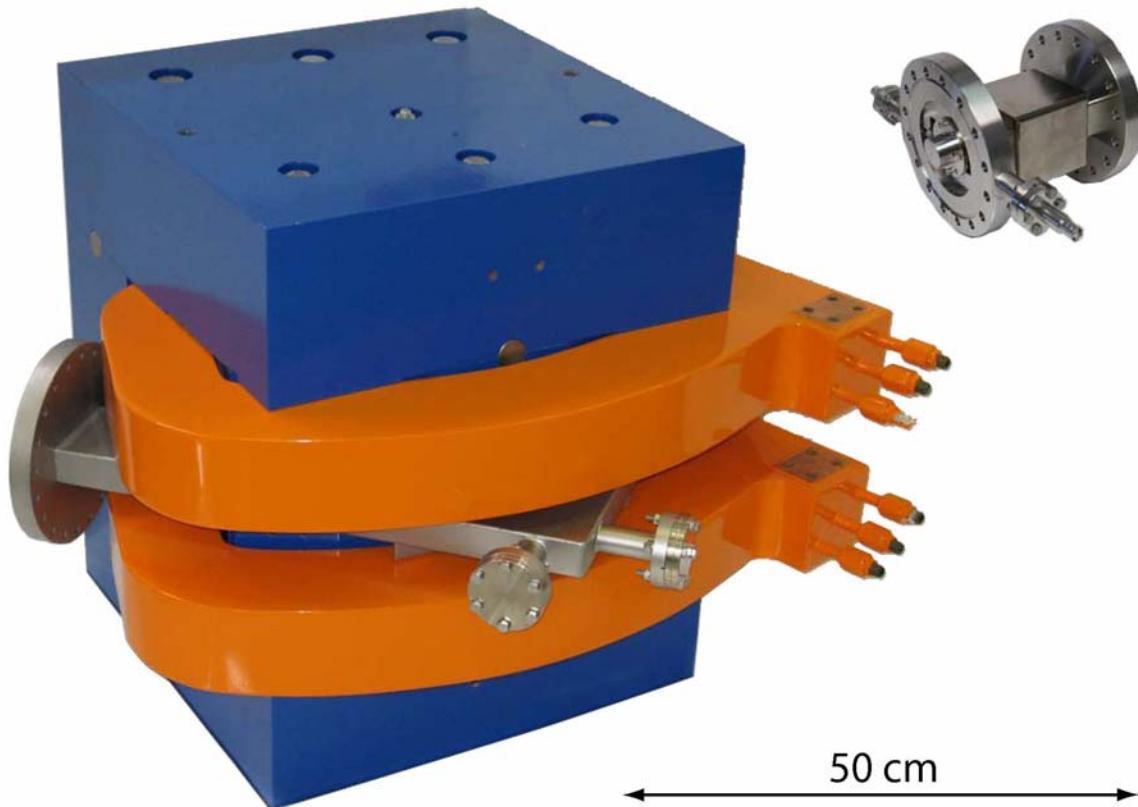
„W“ – Family : Some Ion Extraction Spectra



Dresden EBIS
leaky mode
Xe-129

Comparison of Sizes – Dipole Magnet and Wien Filter

Dipole Magnet



Wien Filter

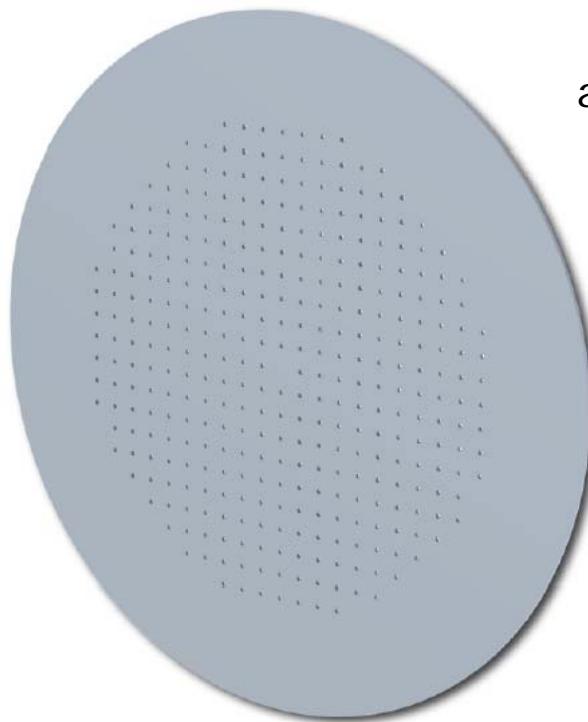
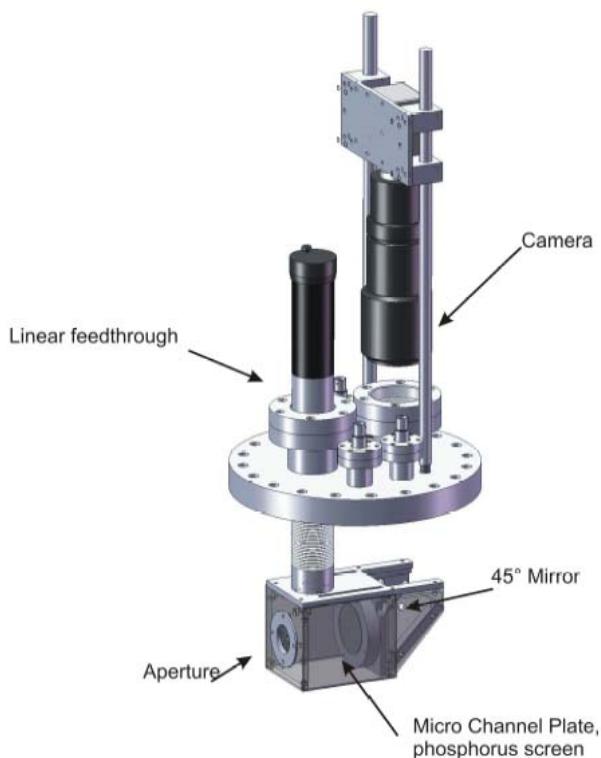


resolution > 80

Wien filter
DREEBIT GmbH
product number 21007
<http://www.dreebit.com>

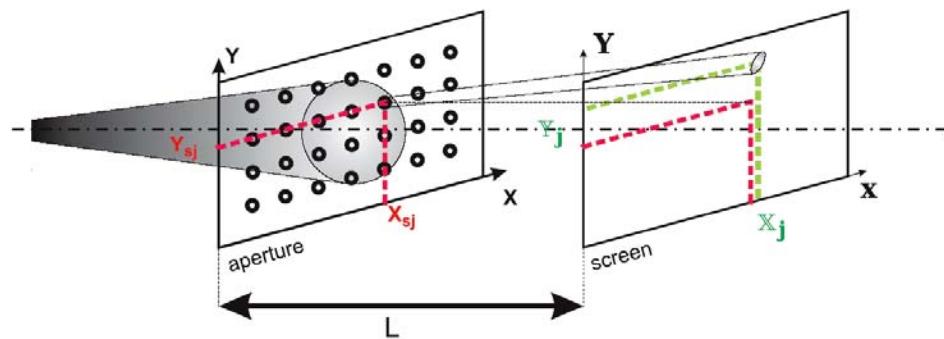


Dresden EBIS-A: Beam Emittance

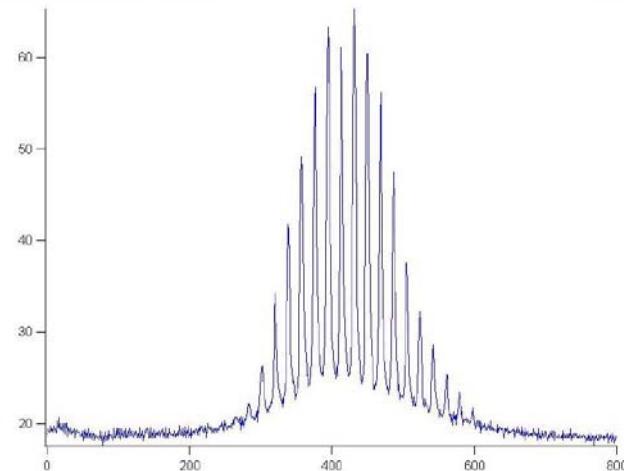
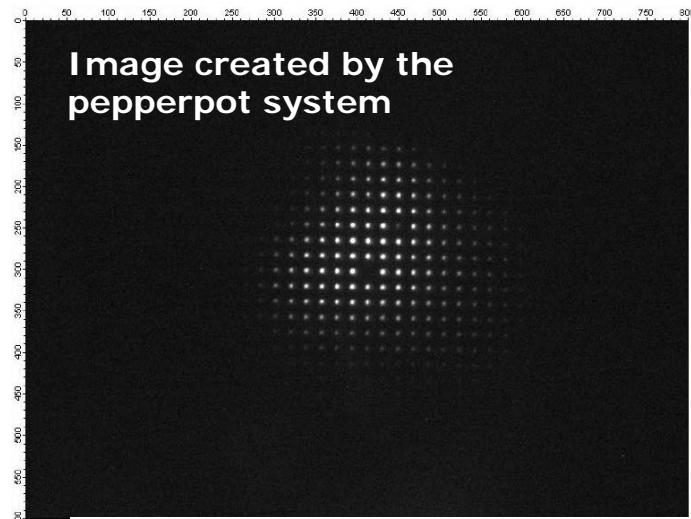
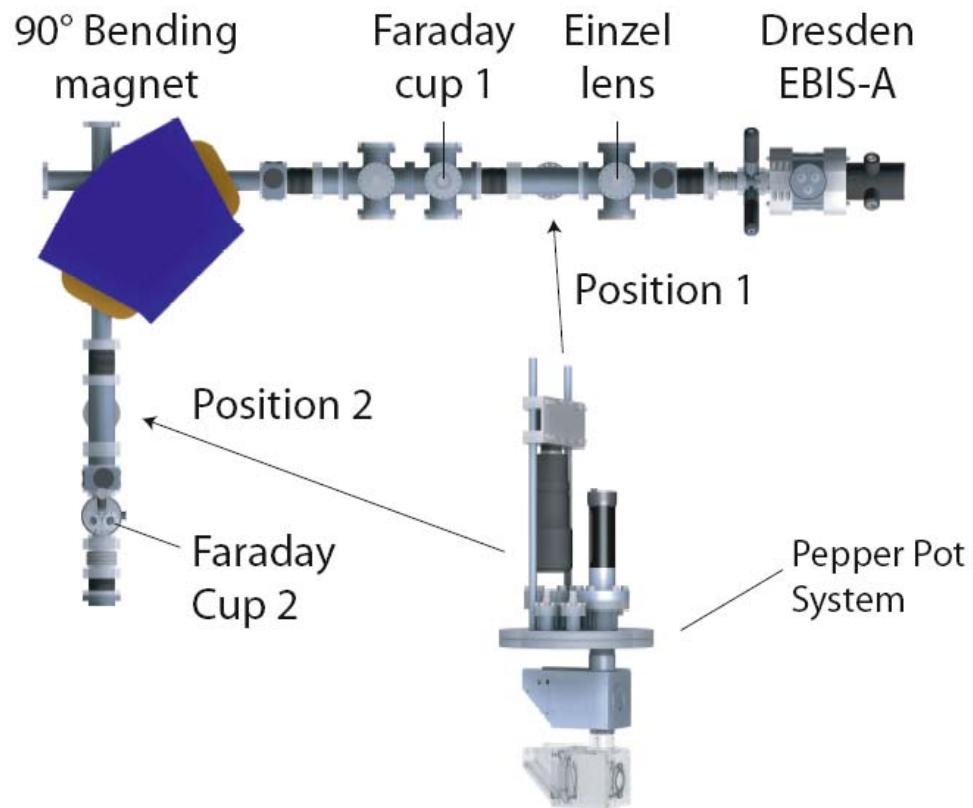


aperture

(a) Pepper Pot System



Dresden EBIS-A: Beam Emittance



RMS Emittance of a C⁶⁺ Ion Beam

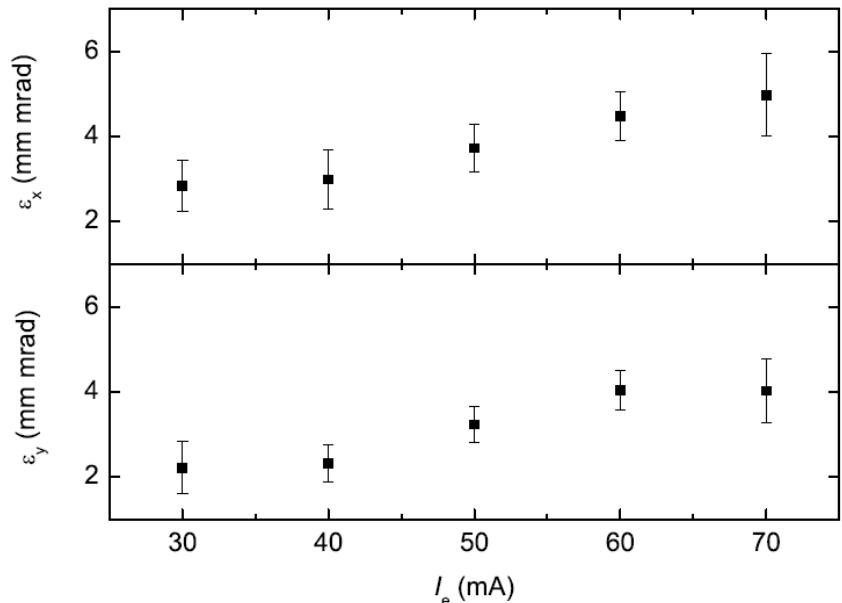
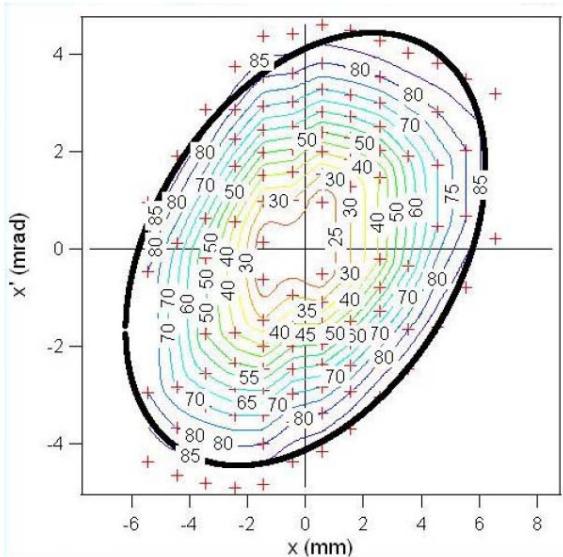


Figure: Trace space plot of the example image (with ellipse)

RMS emittance of a 30 keV C⁶⁺ ion beam

The Next Generation: Dresden EBIS-SC

A new generation of EBIS sources, the Dresden EBIS-SC, is being designed for new fields of applications.

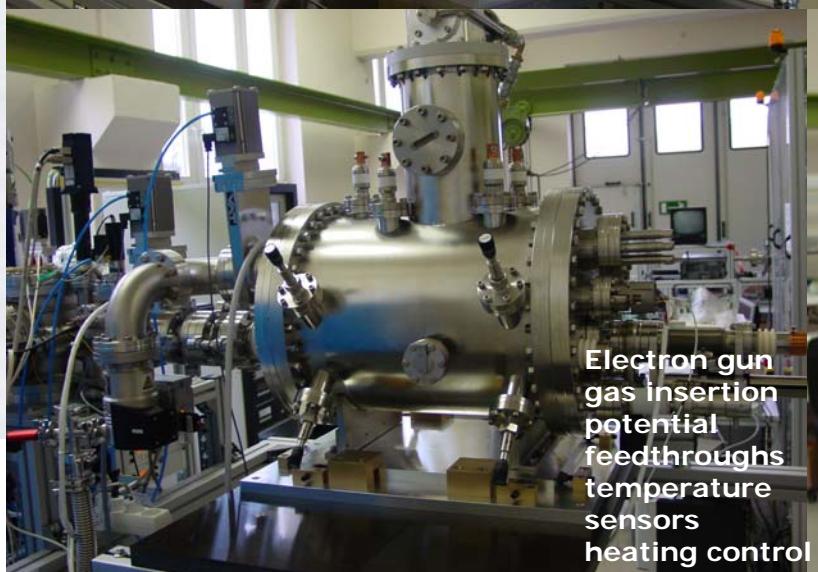
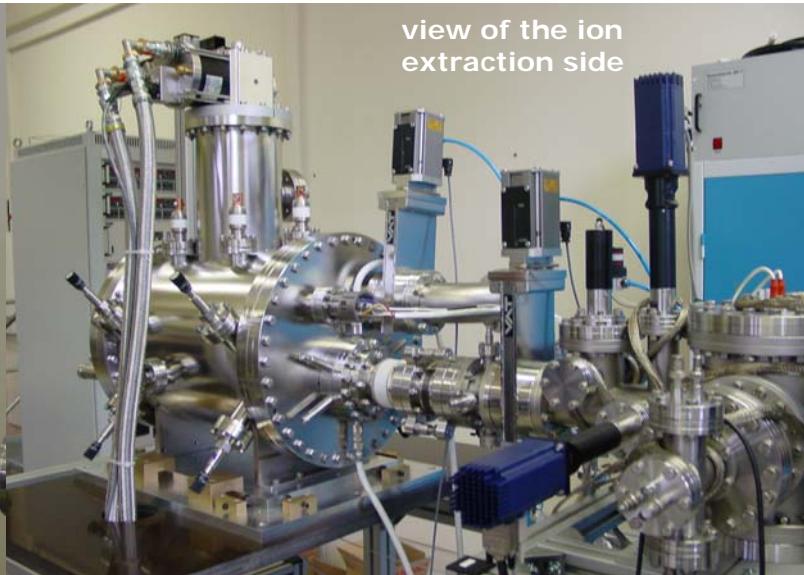
The Dresden EBIS-SC is a superconducting compact ion source which is based on the most modern principles of refrigeration technologies as well as electron-beam technologies.



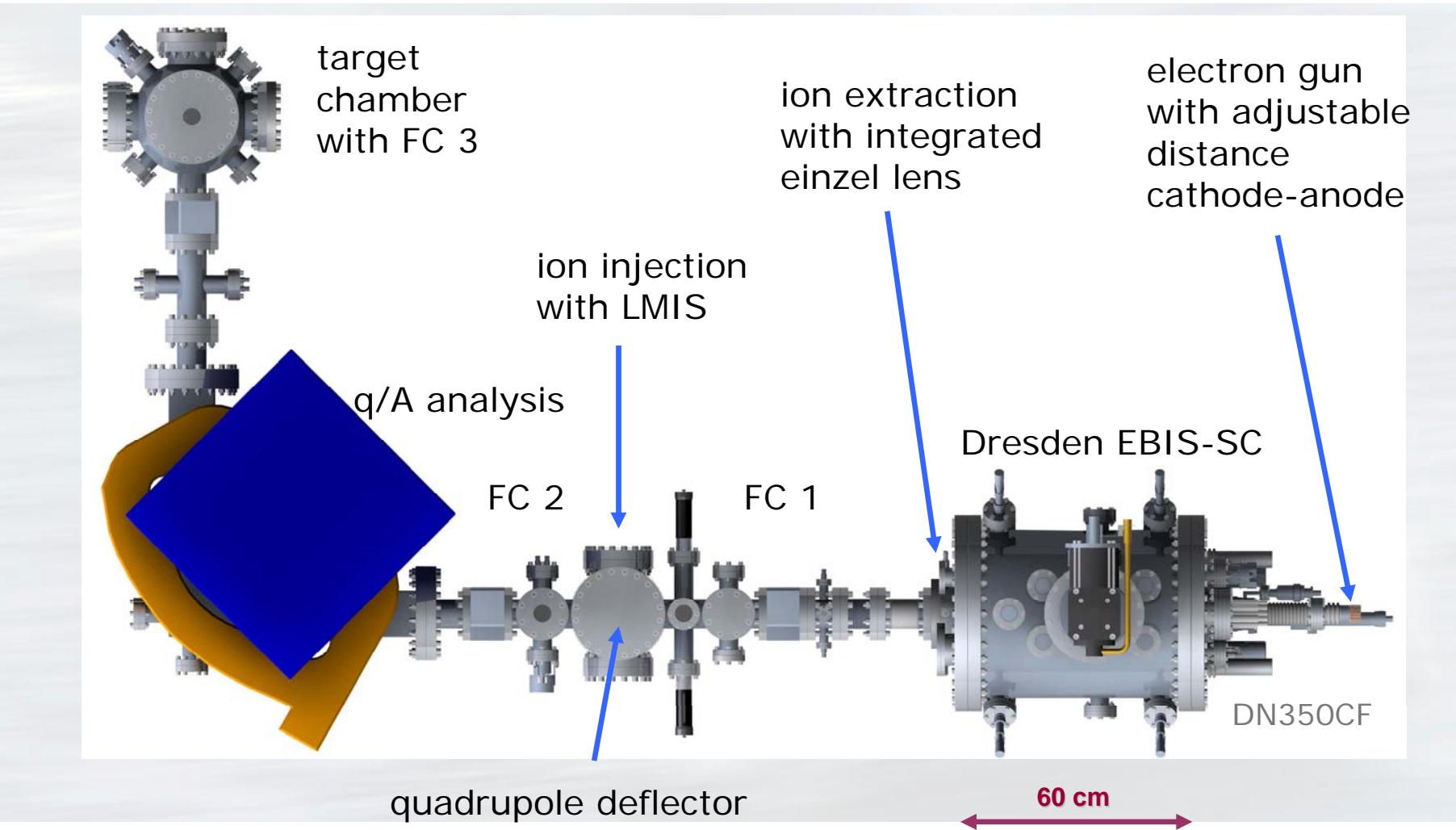
The next generation: Dresden EBIS-SC

Parameter	Value
Total length	approx. 60 cm; DN350CF
Magnetic field (on axis)	up to 6 T
Electron energy	up to 30 keV
Electron current	1 A
→ eff. electron current density	> 1000 A/cm ²
Trap length	20 cm, 8 drift tube segments individual controllable
→ Trap capacity	up to $6 \cdot 10^{10}$ elementary charges

The Dresden EBIS-SC Test Bench



The Dresden EBIS-SC Test Bench



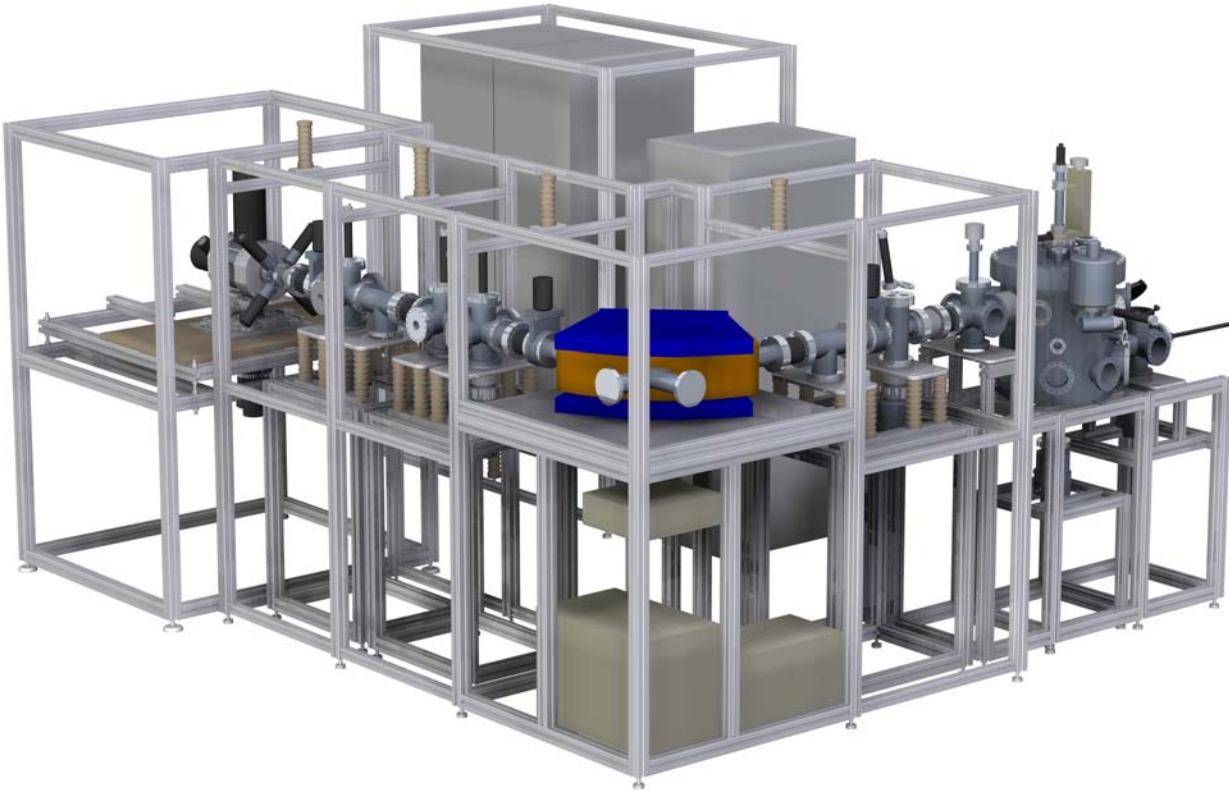
Dresden EBIS-SC: First (preliminary) Results

parameter	value
electron beam current	750 mA
electron energy	10.5 keV
electron beam transmission	0.9984
ion pulse widths	(6...10) μ s

Applications in Accelerator Technology

Low Energy Ion Irradiation Facility

Applications: Low Energy Ion Irradiation Facility



ion deceleration
down to 10 eV^*q

ion acceleration up
to 1.5 MeV

ion pulses from ns
to 100 μs width

DC ion beams

beam diameters
from 500 μm up to
cm

Charge Breeding

Applications: Charge Breeding

Concept:

Primary ion source

→ Beam of low charged ions

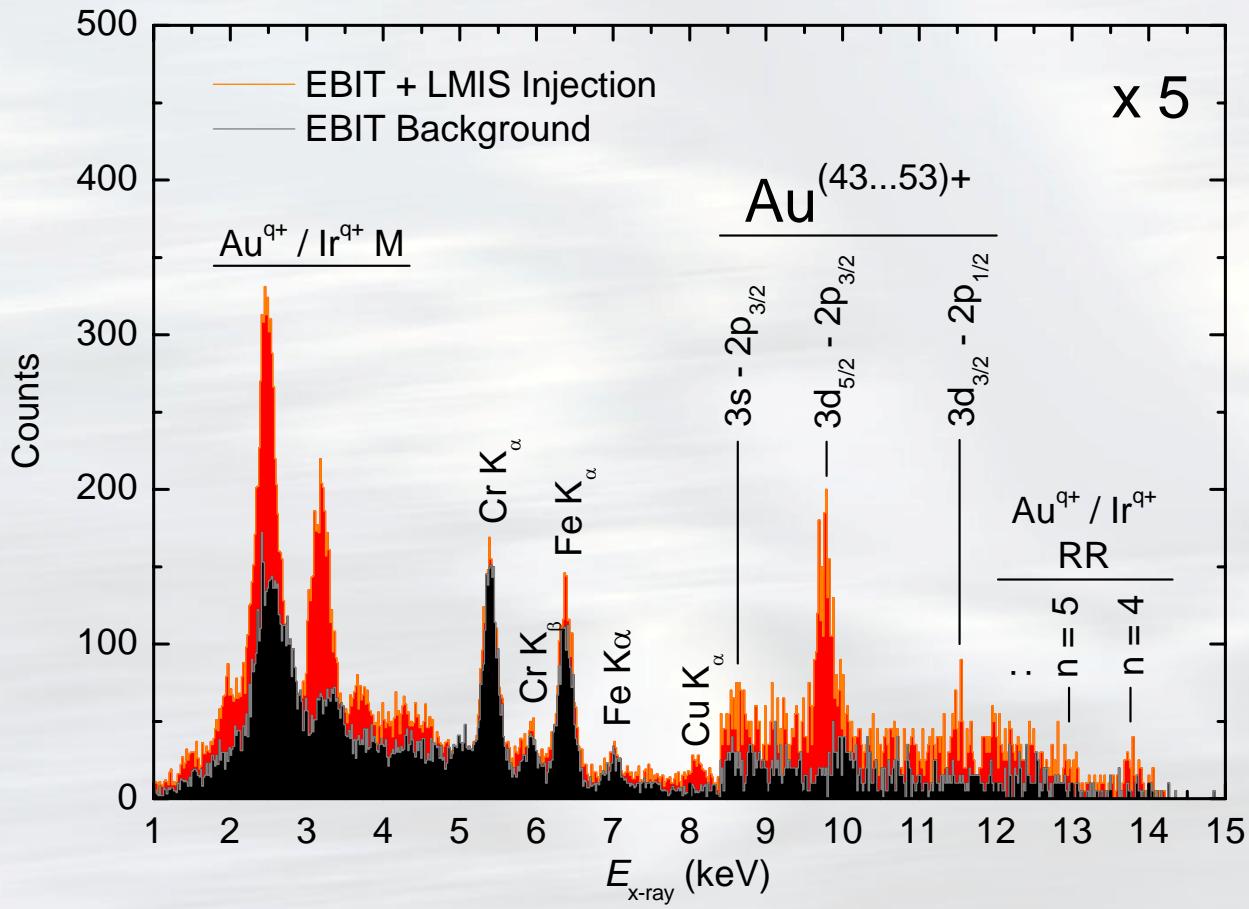
→ Injection into a charge breeding apparatus – ECRIS or EBIT

→ Reextraction of highly charged ions

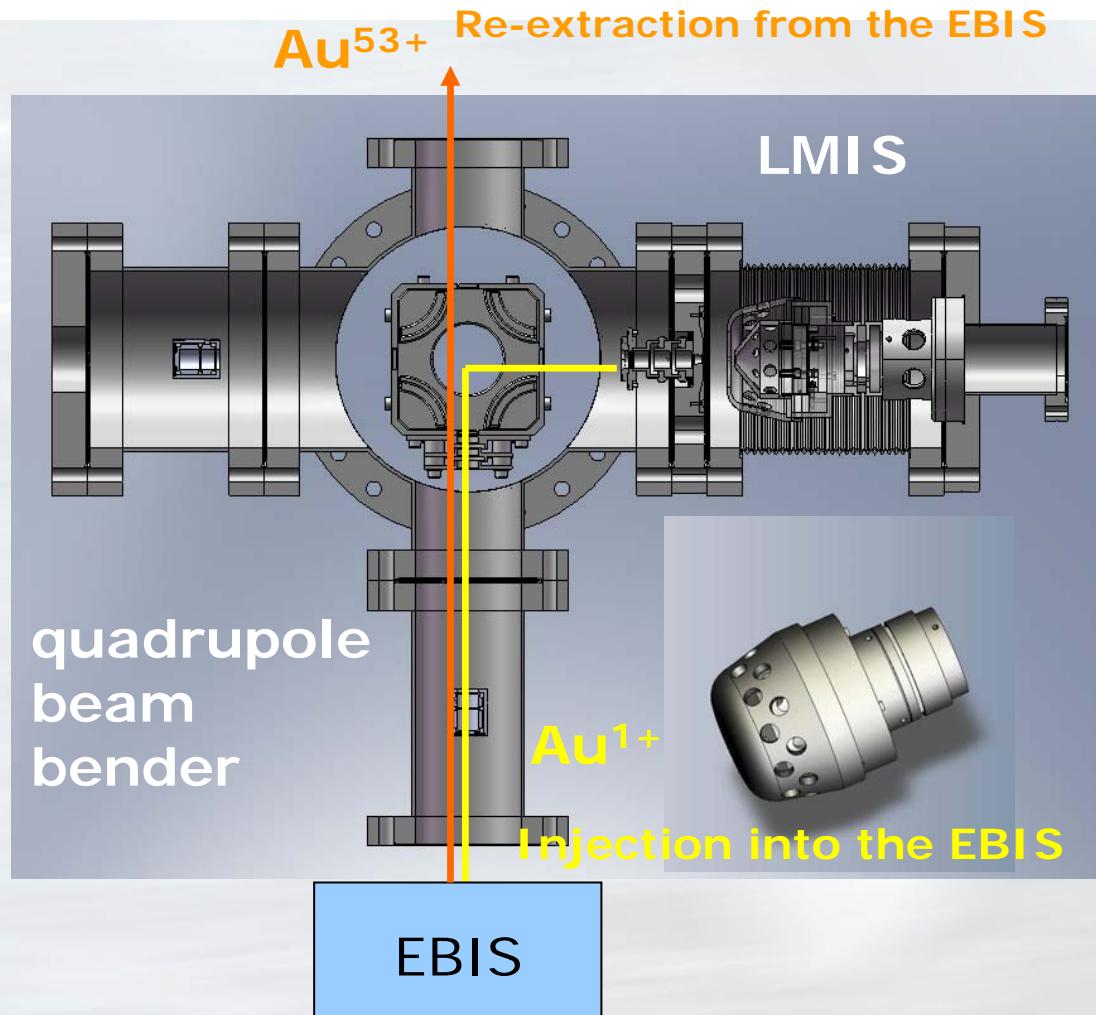
Important properties of a charge breeder:

efficiency, rapidity, and properties of the extracted ion beam

Charge Breeding: Gold



Charge Breeding: Liquid Metal Ion Source with Quadrupole Beam Bender



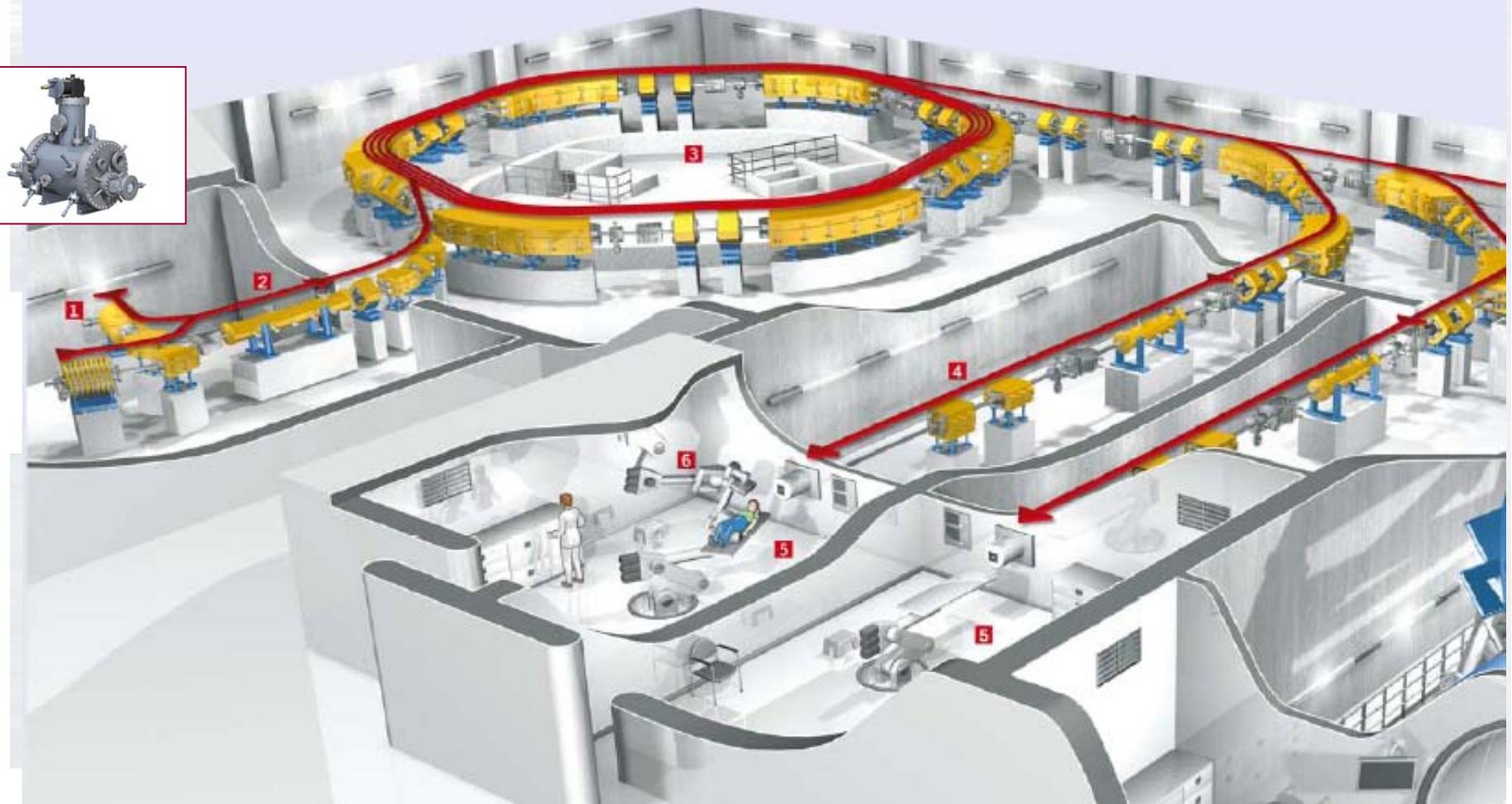
New ion injection techniques for

- Bismuth
- Germanium
- Erbium
- Indium
- Gold
- Ceasium
- Antimony
- Platinum
- Praseodymium
- and others

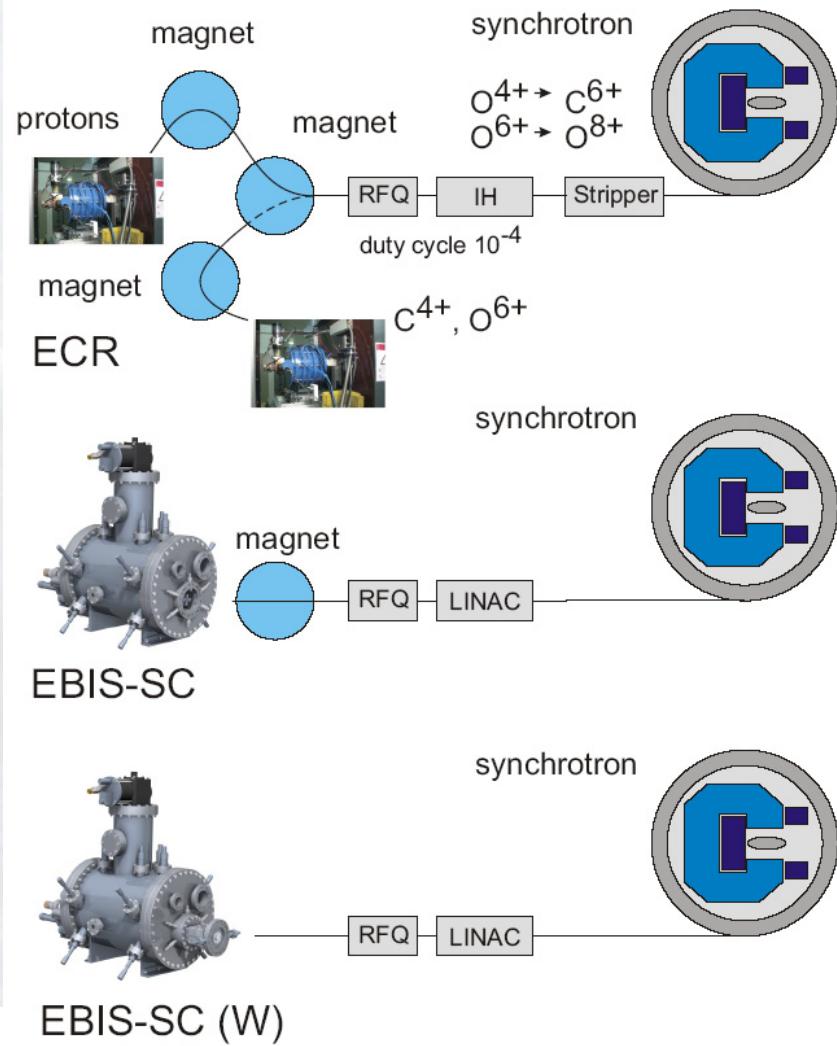
Applications in Medical Therapy Accelerators

Synchrotrons

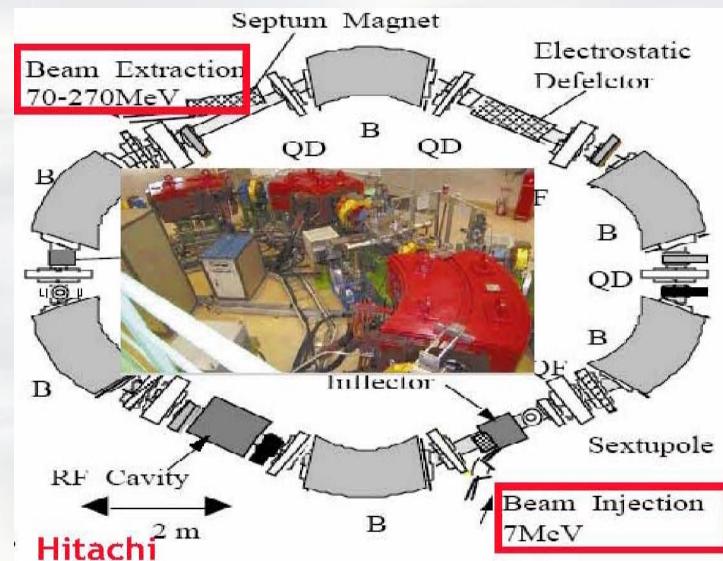
Medical Cancer Therapy – Synchrotrons I



Medical Cancer Therapy – Synchrotrons II



Medical Cancer Therapy – Other Solutions ?

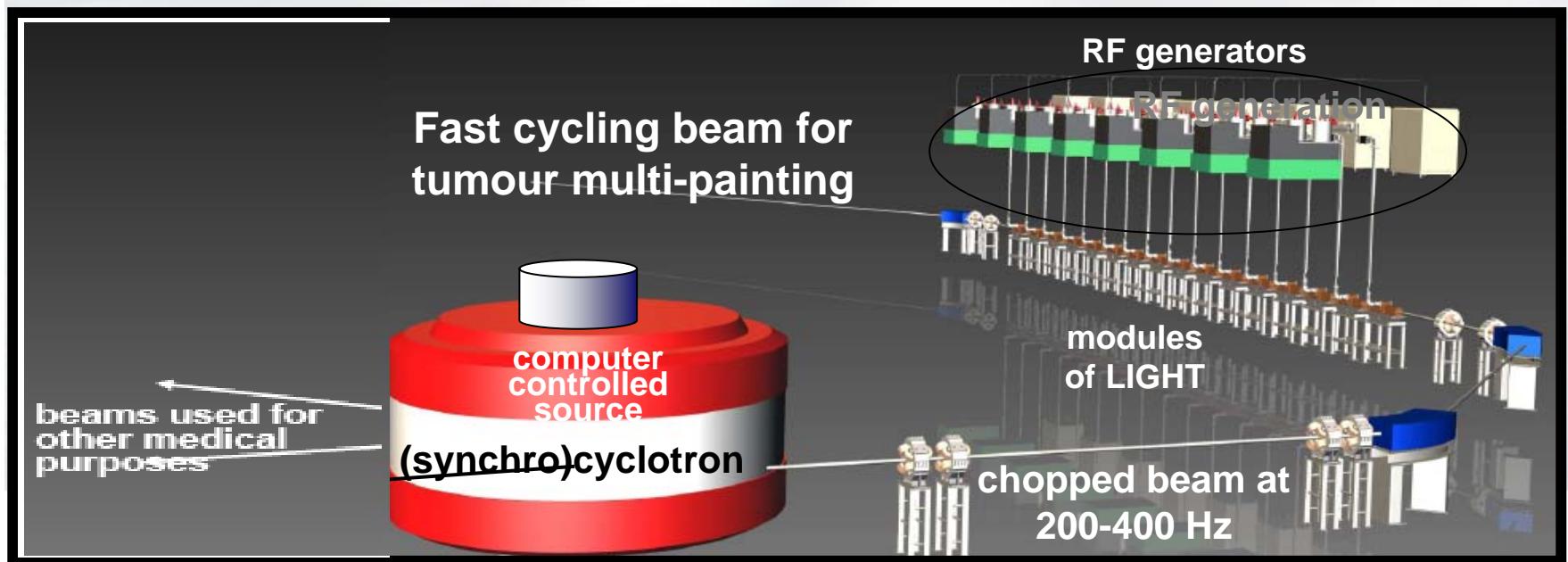




CYCLINAC

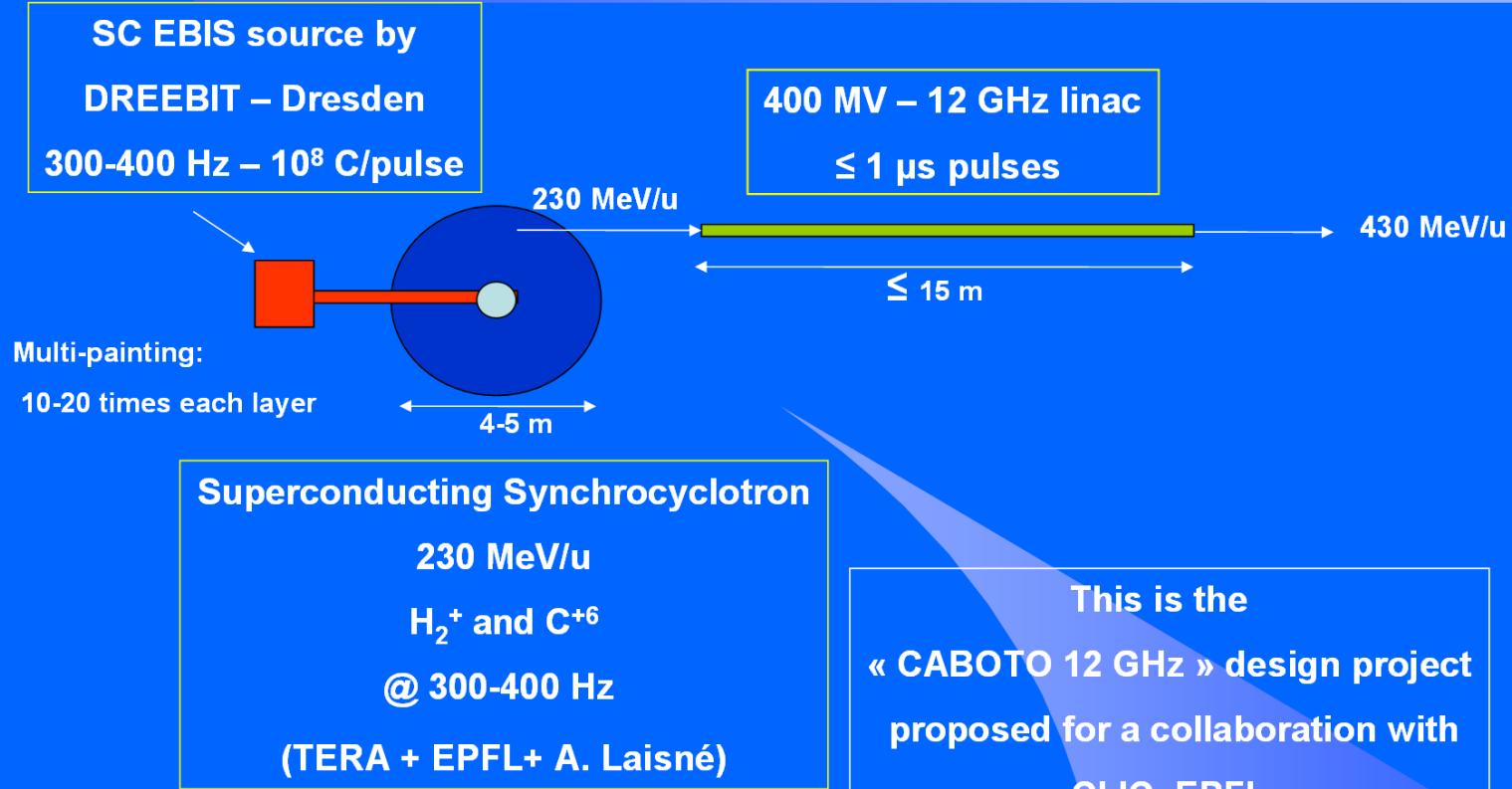
Medical Cancer Therapy – CYCLINAC I

TERA approach to treat moving organs and solve other problems:
high-current cyclotron + novel fast-cycling linac
=
“CYCLINAC”



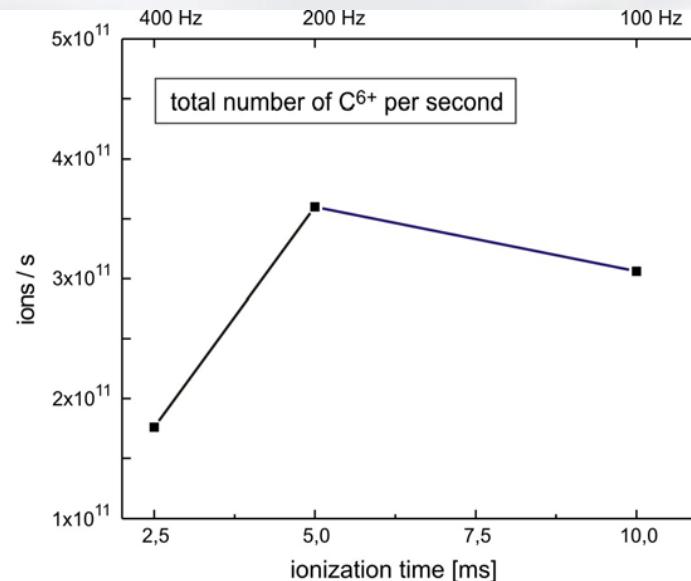
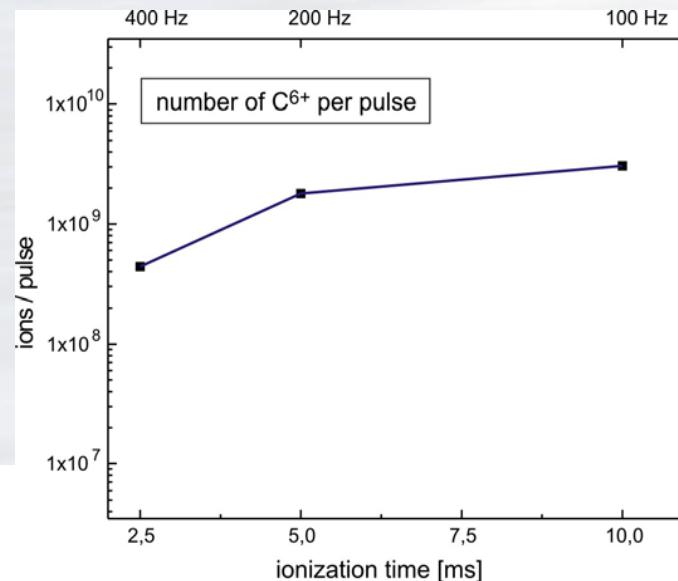
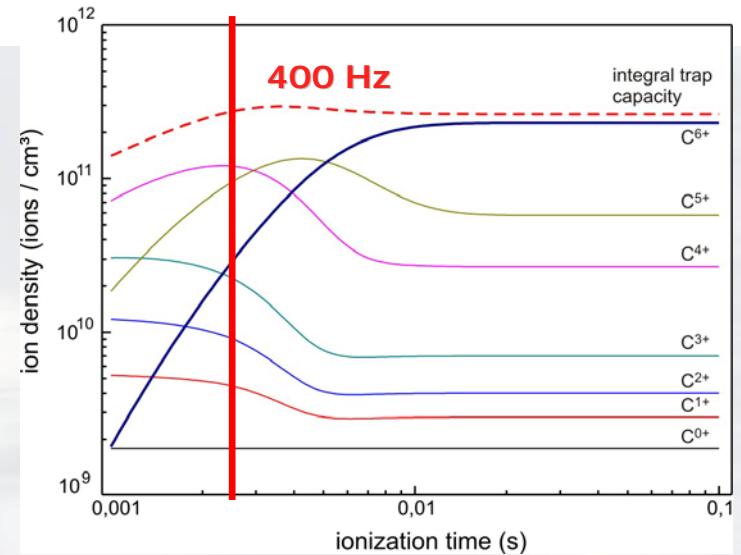
Medical Cancer Therapy – CYCLINAC II

CABOTO at 12 Ghz would be shorter and would consume less power (CNAO consumes 3-4 MW)



Medical Cancer Therapy – CYCLINAC III

Requirement: 1×10^8 ions / puls



The Dresden EBIS/EBIT ion source family consists of four generations of ion sources:

Dresden EBIT

Dresden EBIS

Dresden EBIS-A

Dresden EBIS-SC



small-size room-temperature
sources of highly charged ions

high-performance
superconducting EBIS

Broad fields of applications:

- accelerator technology (medicine, surface science, AMS, ...)
- ion implantation
- nanotechnology
- surface analysis
-

Thank you !



Dr. Zschornack



M. Kreller



A. Silze



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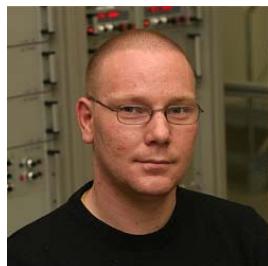
<http://www.tu-dresden.de>



Dr. Ovsyannikov



Dr. Grossmann



R. Heller



U. Kentsch



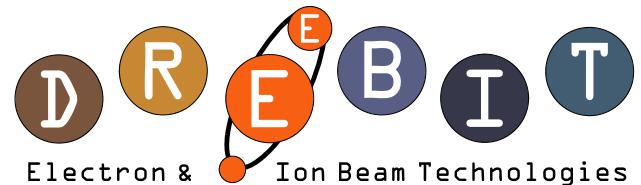
M. Schmidt



A. Schwan



Dr. Ullmann



Electron & Ion Beam Technologies

<http://www.drebit.com>